



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

August 1, 2024  
IGI Report Number **LG645454871**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **8.42 X 5.79 X 3.47 MM**

GRADING RESULTS

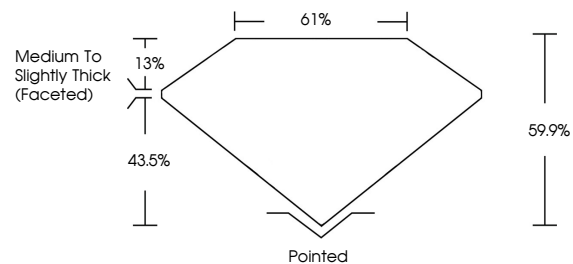
Carat Weight **1.06 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG645454871**

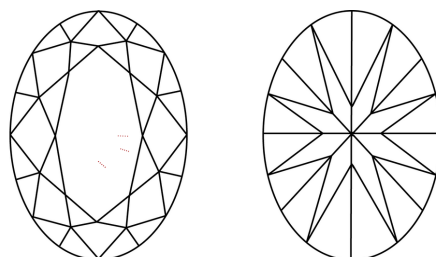
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

COLOR

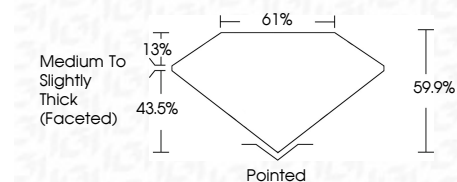
D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**OVAL BRILLIANT**  
8.42 X 5.79 X 3.47 MM  
Carat Weight **1.06 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **60.9%**  
Table **61%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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